



IFW

Docket Number: 061063-0317066  
Client Reference: OSP-18862

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

AKIRA OKUBO, et al.

Group Art Unit: 1763

Application No.: 10/544,178

Examiner: Unassigned

Filed: April 24, 2006

Confirmation No.: 8571

For: INSPECTION METHOD, MANUFACTURING METHOD OF PIECE FOR ANALYSIS,  
ANALYSIS METHOD, ANALYZER, MANUFACTURING METHOD OF SOI WAFER, AND SOI  
WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Copies of cited U.S. patents and patent application publications are not included. Copies of foreign patent documents and non-patent literature are included. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

The reference was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. Please note EP 738004 and JP 2001-319954 cited on the International Search Report were previously filed in the U.S. Patent and Trademark Office on April 24, 2006, therefore, they are not enclosed. Also, please note the enclosed document includes an English abstract and English translation of paragraph 6 on pages 100-103.

Respectfully Submitted,  
PILLSBURY WINTHROP SHAW PITTMAN LLP

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Atty.  
Dkt. No.

M#

Client Ref.

061063

0317066

OSP-18862

Applicant: Akira OKUBO et al.

Appln. No.: 10/544,178

Filing Date: August 1, 2005

Examiner: Unassigned

Group Art Unit: 1763

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Date: April 6, 2007

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of

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## U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR					
	BR					
	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					
	NR					

## FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
	OR							
	PR							
	QR							
	RR							
	SR							
	TR							
	UR							
	VR							
	WR							
	XR							

## OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

YR	"Saishin Kotai Hyomen/Bisho Ryoiki no Kaiseki Hyoka Gijutsu, (Recent technologies for analysis and evaluation of solid surface and minute region," Riaraizu Sha, March 31, 1991, pages 95-104; particularly, pages 100-103.	X		X	
ZR	International Search Report for International Application No. PCT/JP03/13271 dated February 3, 2004.				
AAR					
BBR					

Examiner

Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.